

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:

Naoki Abe

Confirmation No. 8684

Serial No. 10/749,518

Group Art Unit: 2167

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Examiner: Timblin, Robert M.

For: **RESOURCE-LIGHT METHOD
FOR OUTLIER DETECTION**

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Commissioner for Patents
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*entered per
ROE
4-12-07*

AMENDMENT UNDER 37 C.F.R. § 1.116

Sir:

In response to the Office Action mailed December 12, 2006, please amend the above-identified patent application as follows:

Listing of the Claims begins at page 2 of this paper.

Remarks begin at page 10 of this paper.